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PATENT  
ATTORNEY DOCKET NO.: 049128-5144

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	Confirmation No.: 8591
Byung Chul AHN, et al.	)	
	)	Group Art Unit: 2879
Application No.: 10/774,701	)	
	)	Examiner: <i>Unassigned</i>
Filed: February 10, 2004	)	
	)	
For: METHOD OF PATTERNING TRANSPARENT CONDUCTIVE FILM, THIN FILM TRANSISTOR SUBSTRATE USING THE SAME AND FABRICATING METHOD THEREOF	)	

Commissioner for Patents  
U.S. Patent and Trademark Office  
2011 South Clark Place  
Customer Window  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

**INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)**

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), Applicants bring to the attention of the Examiner the attached document. To the best of the undersigned's knowledge, this Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits for the above-referenced application, and no fees are believed to be necessary.

The listed document was cited in a Korean Office Action dated March 30, 2005. A copy of the Korean Office Action along with the listed document is attached.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that the listed document is material or constitutes "Prior Art." If it should be determined that the listed document does not constitute "Prior Art" under

United States law, Applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of such document.

Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed document, should the document be applied against the claims of the present application. If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 50-0310.

Respectfully submitted,

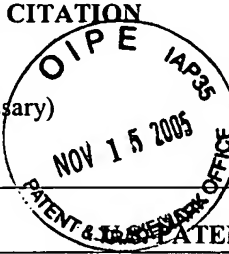
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Dated: Nov 15, 2005

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<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary) <b>PTO Form 1449</b>				Attorney Docket No. 049128-5144		Application No.: 10/744,701			
				Applicants: Byung Chul AHN, et al.				<b>PAGE 1 of 1</b>	
				Filing Date: February 10, 2004			Group Art Unit: 2879		
<b>PATENT DOCUMENTS</b>									
*Examiner Initial		Document Number	Date	Name	Class	Sub Class	Filing Date		
<b>FOREIGN PATENT DOCUMENTS</b>									
		Document Number	Date	Country	Class	Sub Class	<u>Translation</u> YES NO		
		1997-0023747 (abstract and first page only)	May 30, 1997	Korea					
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>									
Examiner					Date Considered				
Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									